

Substitute for form 1449A/PTO & 1449B/PTO			<b>Complete if Known</b>		
<b>FIRST INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>  (use as many sheets as necessary)			Application Number	10/743,815	
			Filing Date	December 24, 2003	
			First Named Inventor	Daniel Kräbmer, et al.	
			Examiner Name	Unassigned	
Sheet	1	of	1	Attorney Docket Number	007413-071

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Examiner Initials	Document Number	Kind Code (if known)	Name of Patentee or Applicant of Cited Document	Issue/Publication Date (MM-DD-YYYY)
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NON-PATENT LITERATURE DOCUMENTS	
Examiner Initials	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.
D.R.	C. VAN PESKI, "Behavior of Fused Silica Under 193 nm Irradiation", International Sematech publication, Technology Transfer #00073974A-TR, July 25, 2000, International Sematech.
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↓	V.S. KHOTIMCHENKO, et al., "Determining the Content of Hydrogen Dissolved in Quartz Glass Using the Methods of Raman Scattering and Mass Spectrometry", Zhurnal Prikladnoi Spektroskopii, 46(6), Pages 987-991, 1986 (with English-language summary at end).
D.R.	D.M. DODD, et al., "Optical Determinations of OH in Fused Silica", J. Appl. Physics, page 3911, 1966.

Examiner Signature	<i>[Signature]</i>	Date Considered	6/9/05
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with M.P.E.P. § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.